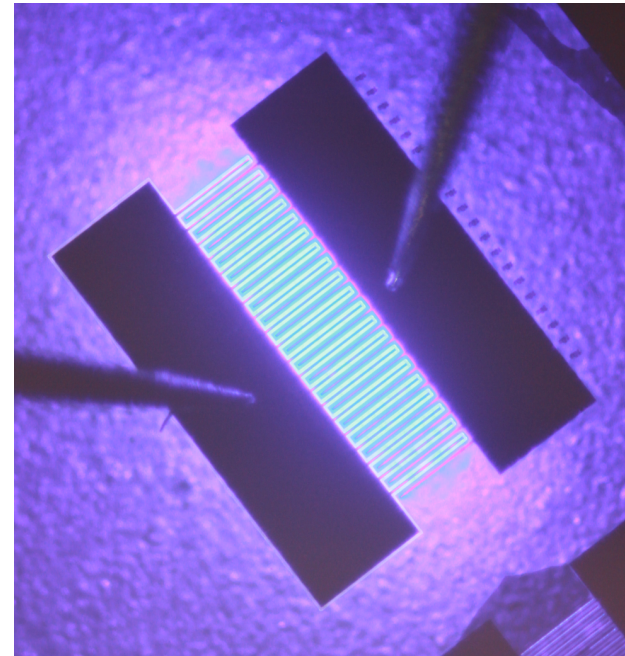
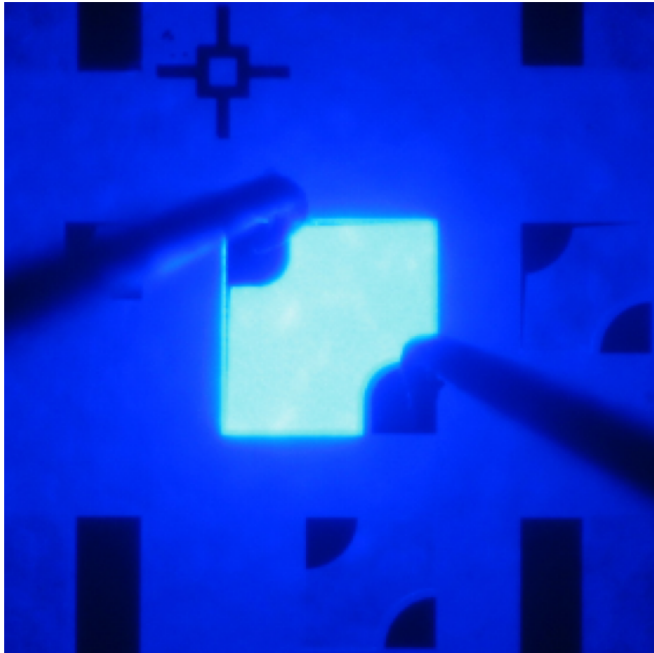


# Optoelectronics

## ELEC-E3210



## Lecture 4

# Outline

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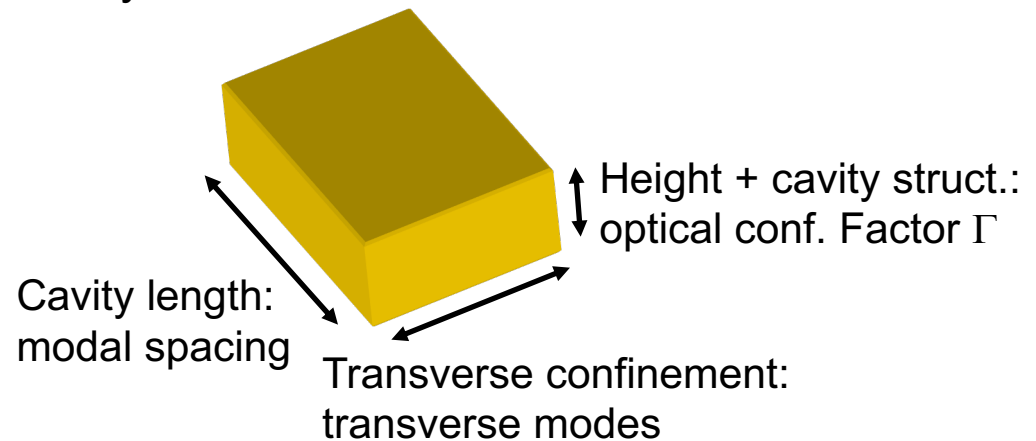
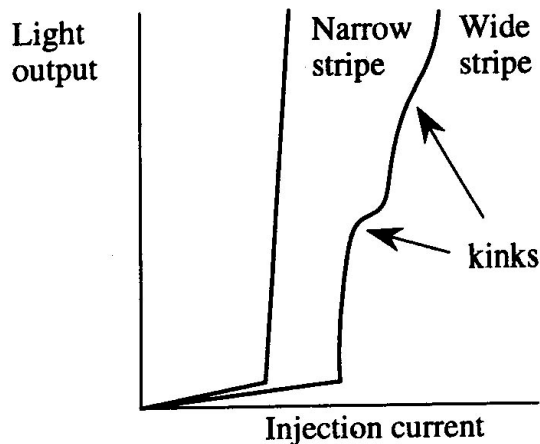
- 1 Lateral confinement: index and gain guiding
- 2 Surface emitting lasers
- 3 DFB, DBR, and C3 lasers
- 4 Quantum well lasers
- 5 Mode locking

*P. Bhattacharya: chapters 6&7*

*J. Singh: chapter 10&11*

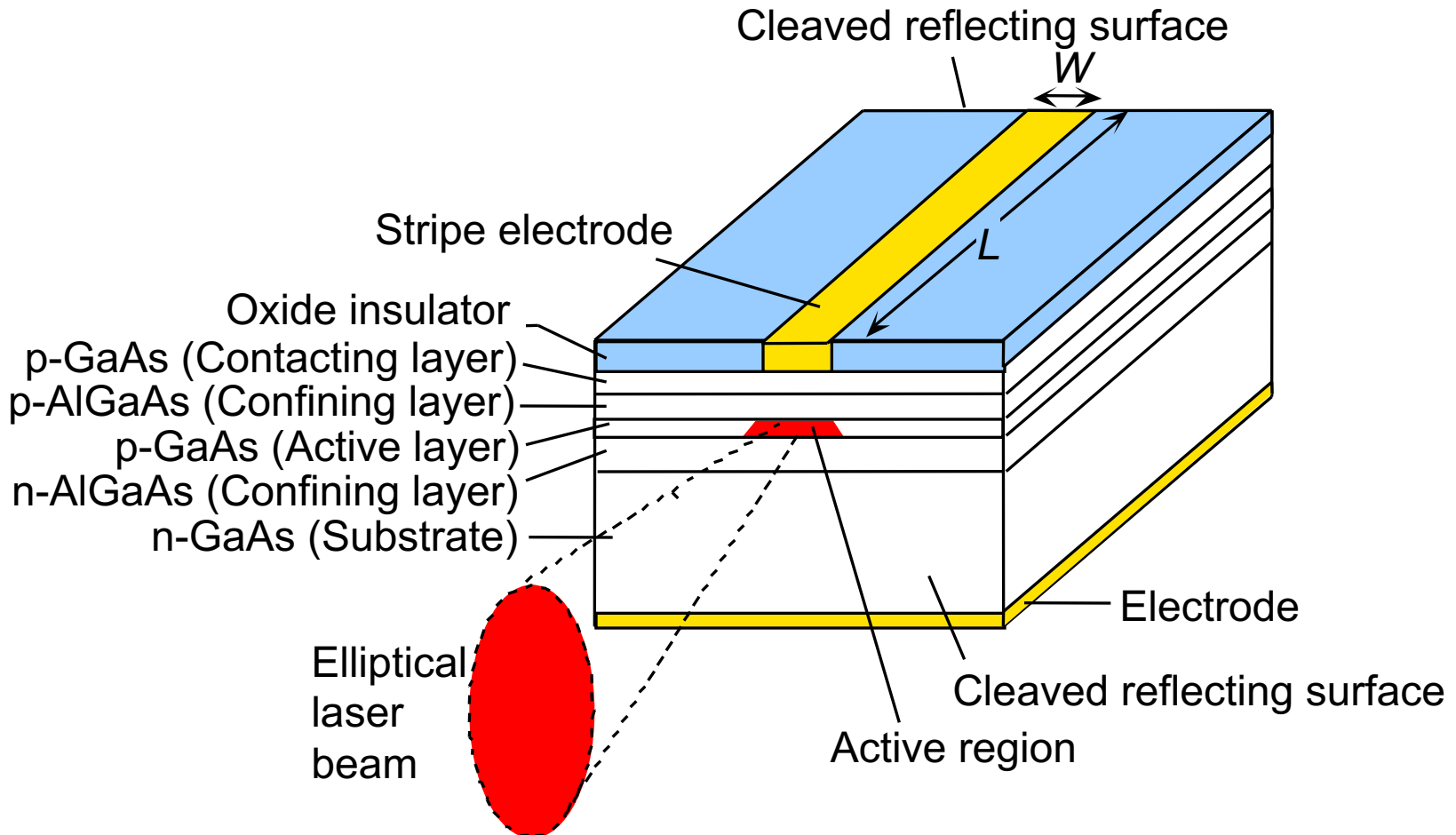
# Lateral confinement

- The Fabry-Perot cavity has a certain lateral dimension which determines the transverse modes of the light that is emitted → there may be several transverse modes with closely spaced frequency
- To avoid "kinks" in the output power a strong lateral confinement has to be ensured
- Lateral confinement may be achieved by two approaches
  - 1) **gain guided cavities** (lateral variation of optical gain): stripe and ridge geometries
  - 2) **index guided cavities** (lateral variation of refractive index): buried heterostructure geometry

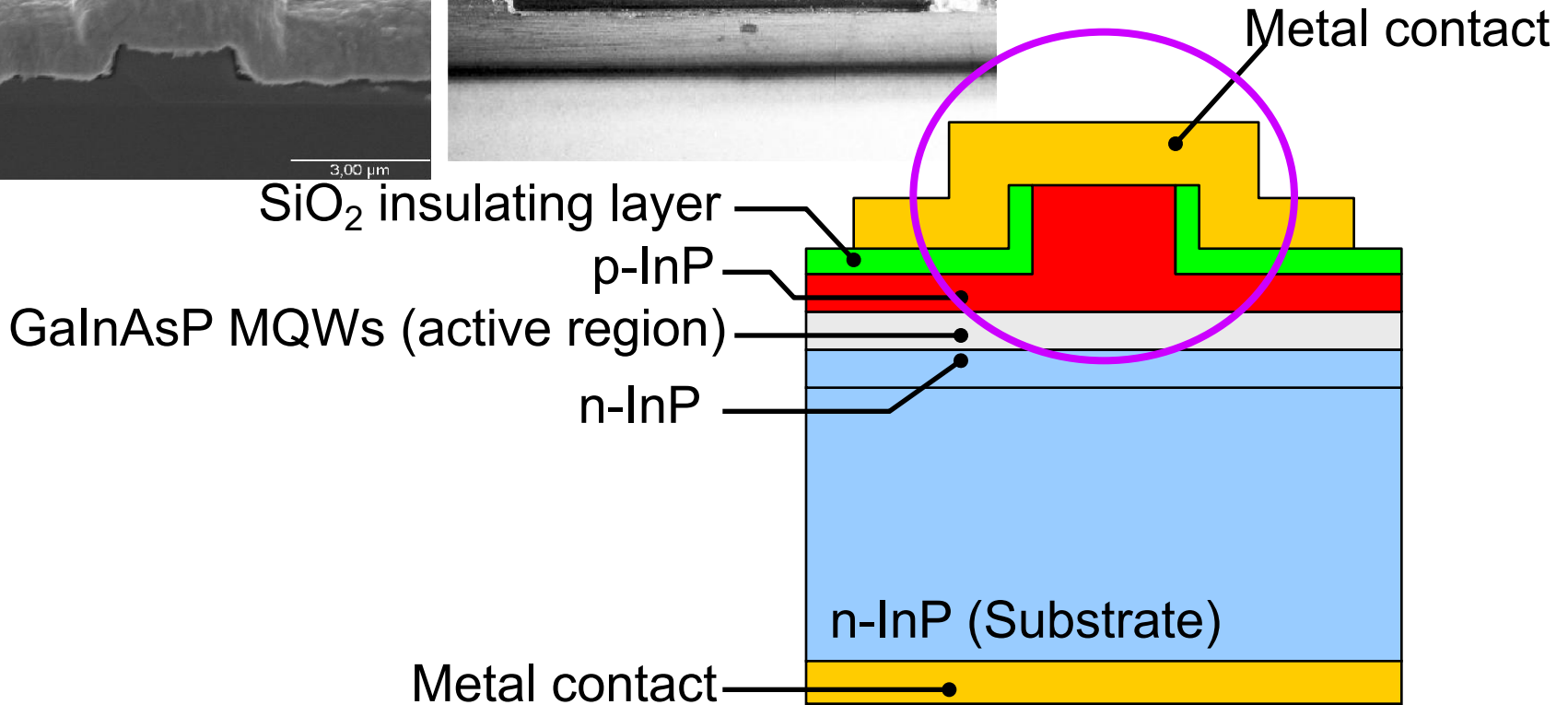
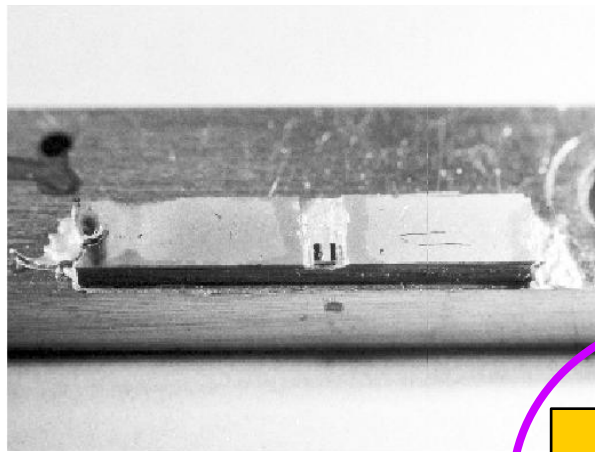
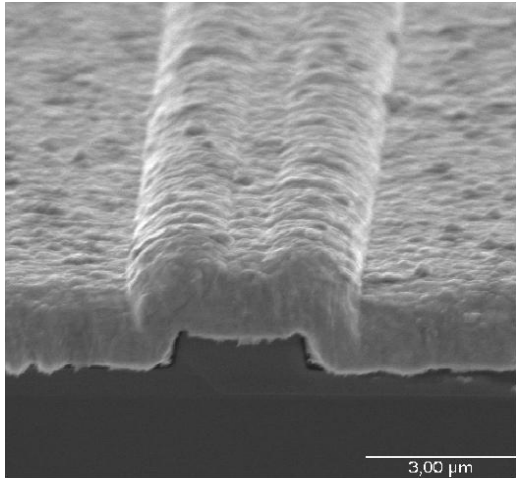


# Gain-guided lasers: stripe geometry

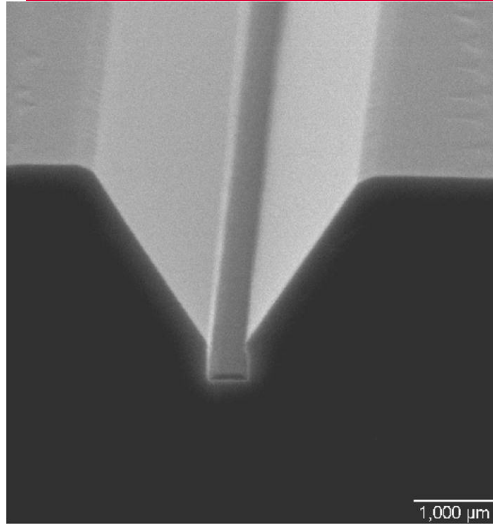
Transverse dimension of the active region 1 – 10  $\mu\text{m}$



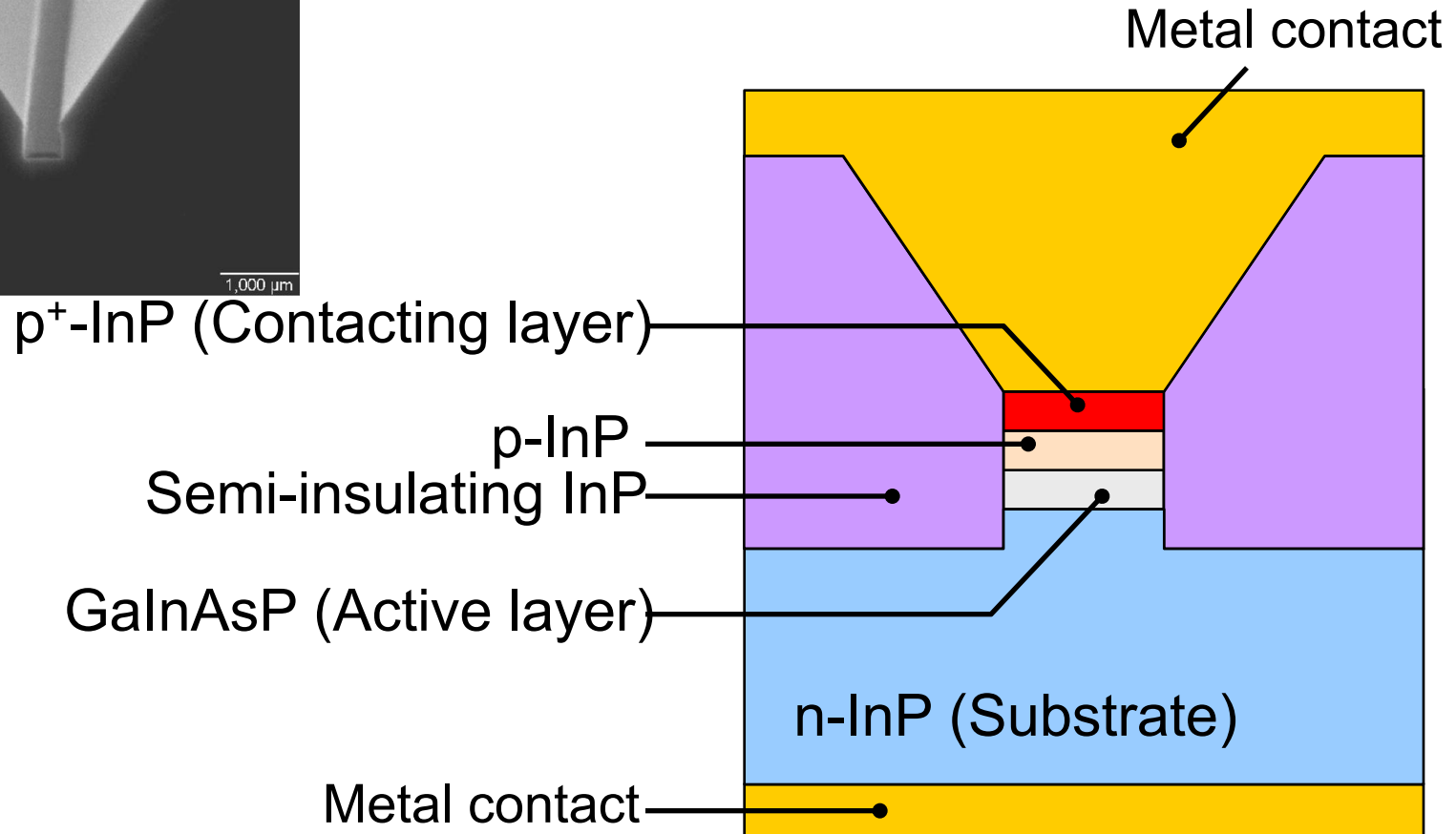
# Gain-guided lasers: ridge geometry

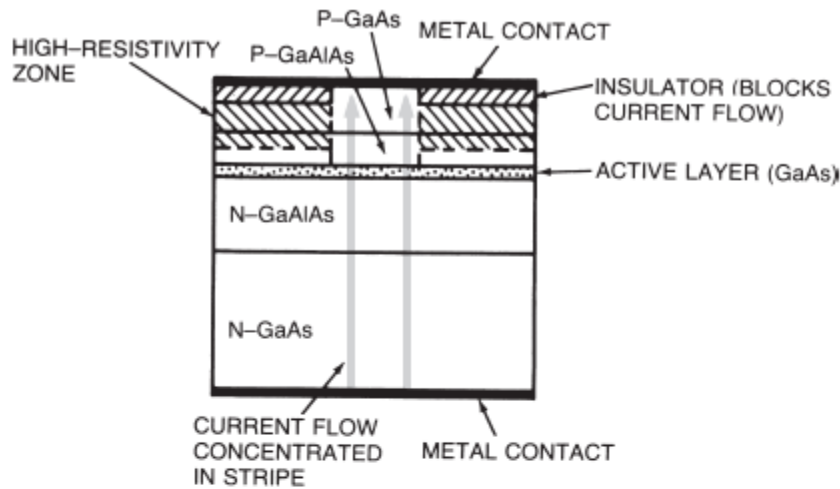


# Index-guided lasers: buried heterostructure

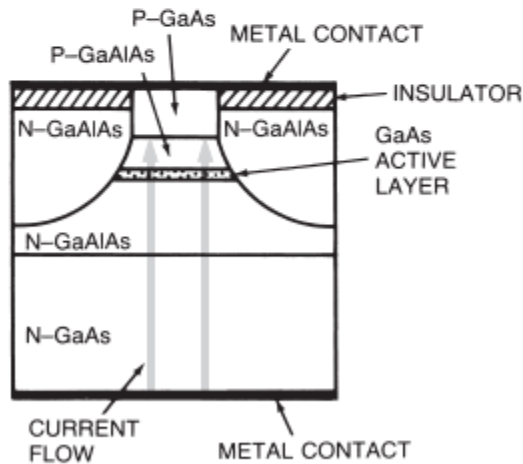


Mesa-etching + re-growth





(A) Gain-guided laser.



(B) Index-guided laser.

- Gain-guided lasers are simple to make

- Index-guided lasers confine light better, producing better beam quality

Figure 9-12. End views of gain-guided and index-guided lasers.

# Images of real packaged lasers

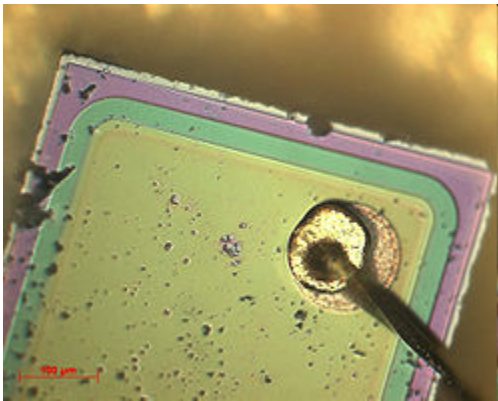
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A packaged laser diode with penny for scale



Image of the actual laser diode chip (shown on the eye of a needle for scale) contained within the package shown in the left image.



A visible light micrograph of a laser diode taken from a CD-ROM drive. Visible are the P and N layers distinguished by different colours. Also visible are scattered glass fragments from a broken collimating lens.



# Outline

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- 1 Lateral confinement: index and gain guiding
- 2 Surface emitting lasers
- 3 DFB, DBR, and C3 lasers
- 4 Quantum well lasers
- 5 Mode locking

*P. Bhattacharya: chapters 6&7*

*J. Singh: chapter 10&11*

# Vertical Cavity Surface Emitting Laser (VCSEL)

- In a **Vertical Cavity Surface Emitting Laser** (VCSEL) light is emitted perpendicularly to the layered structure
- The resonant cavity is particularly short ( $L < \lambda$ ) and the active region has a very small volume.

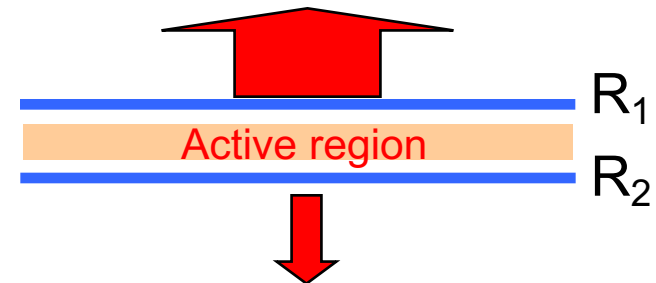
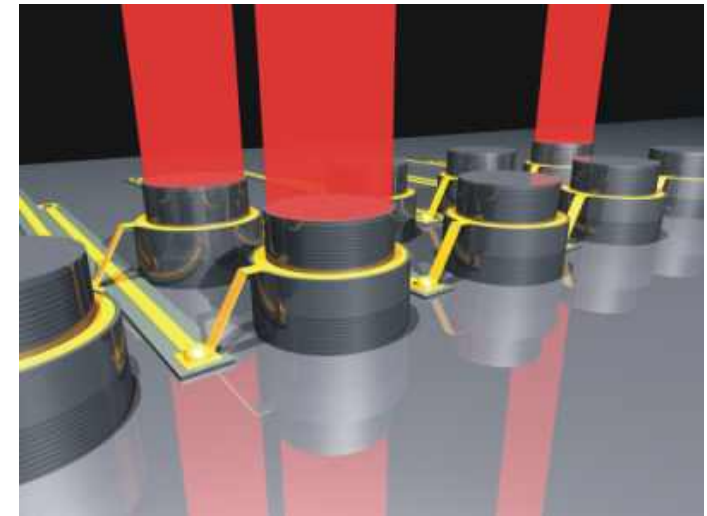
$$\Gamma g_{th} = \alpha - \frac{1}{L} \ln(R_1 R_2) \quad \text{and } L \text{ small}$$



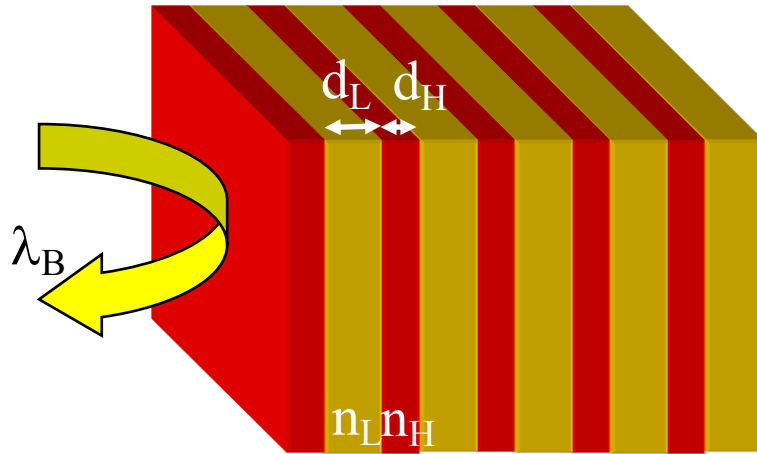
$R_1$  and  $R_2$  need to be close to 100% in order to achieve reasonable threshold gain

~~Metal mirror?~~

~~High reflectivity coating?~~



# Distributed Bragg Reflector (DBR)

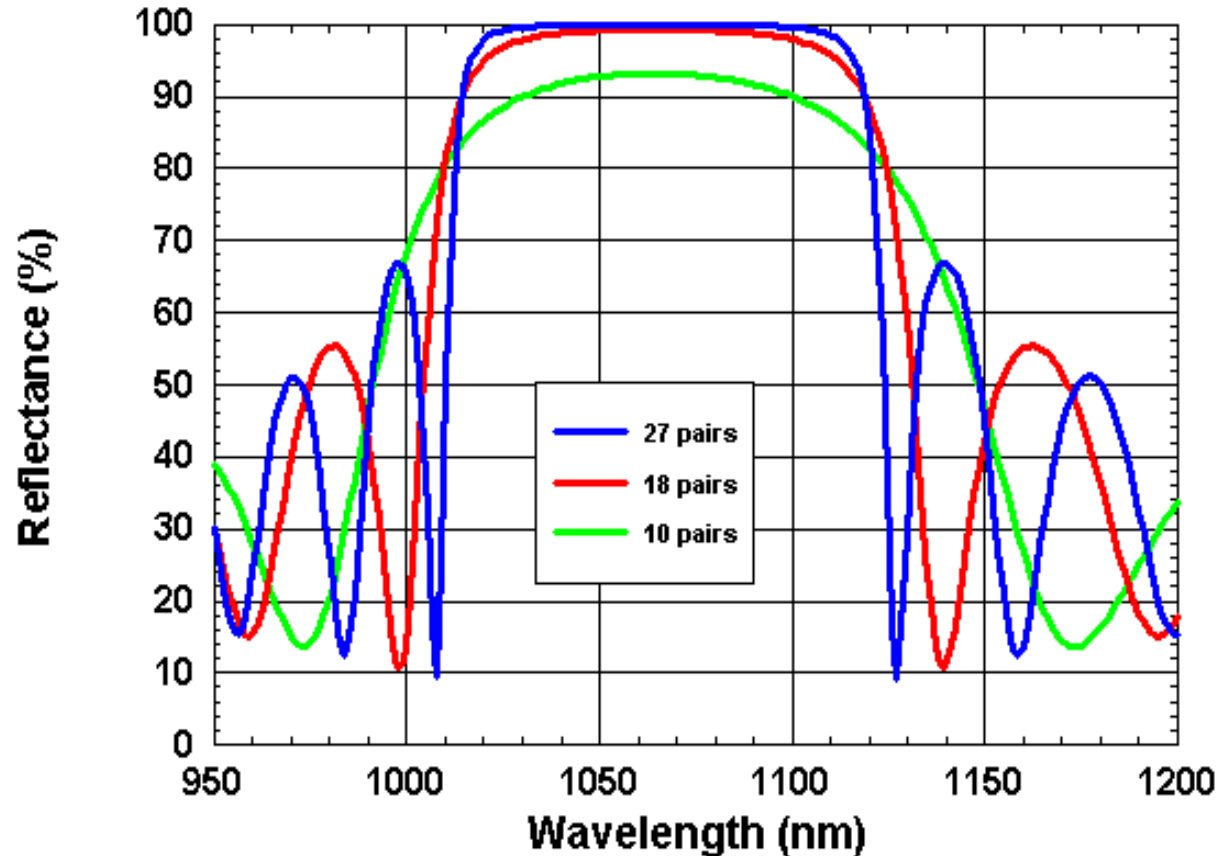


$$R = \left( \frac{1 - \left( \frac{n_L}{n_H} \right)^{2N}}{1 + \left( \frac{n_L}{n_H} \right)^{2N}} \right)^2 \quad n_L d_L + n_H d_H = \frac{\lambda_B}{2}$$

- DBR: multilayer-stack of alternate high- and low-index films
- Basic principle: constructive reflection of light at a series of subsequent interfaces
- High reflectivity around Bragg wavelength  $\lambda_B$
- Design rules:
  1.  $d_L = \frac{\lambda_B}{4n_L}$   $d_H = \frac{\lambda_B}{4n_H}$
  2. Odd number of layers
  3. R has to be higher than 99%
  4. Mirror has to be transparent to the laser

# DBR

Example: AlAs/GaAs reflector



Constructive interference leads to the formation of a stopband

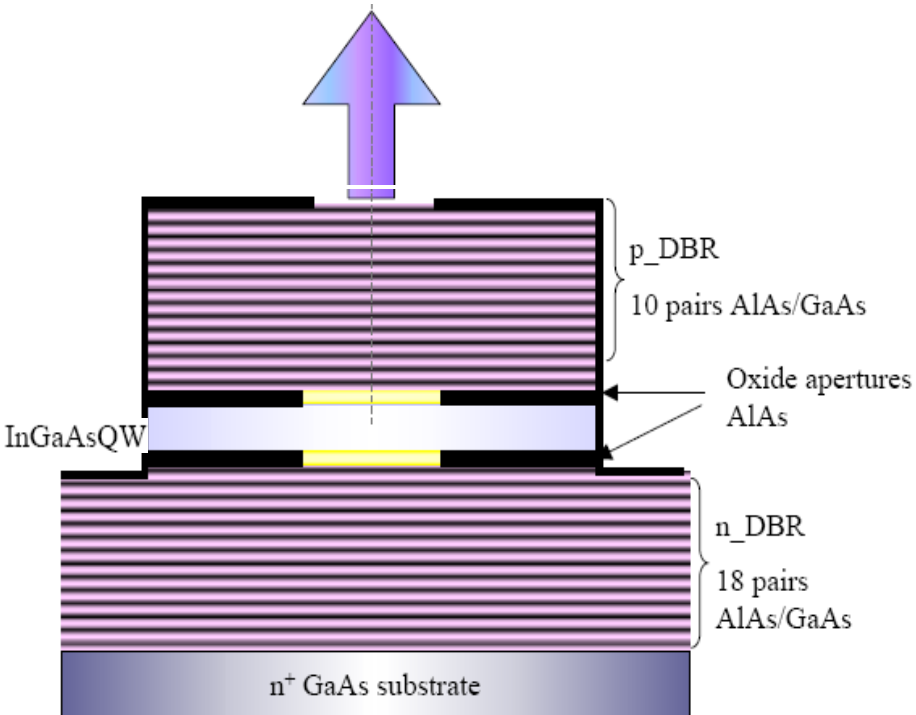
# DBR

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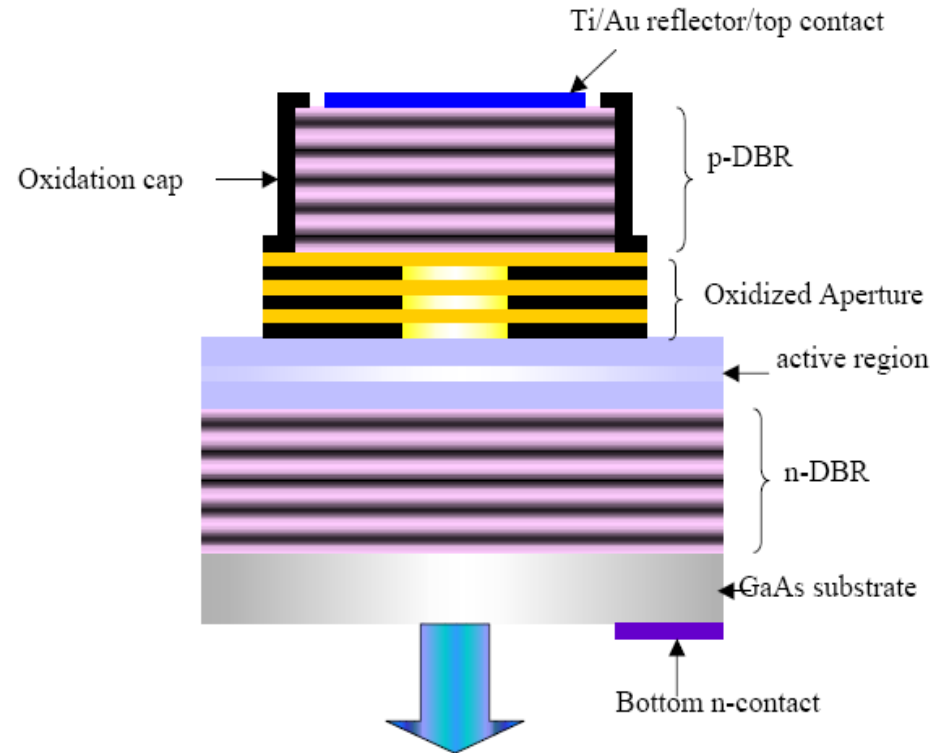
- Several possibilities exist to make DBRs of the III-V's:
  - AlGaAs/GaAs
  - InGaAsP/InP
  - AlGaInP/AlInP
  - GaP/AlGaP
- DBRs serve as pathways for the injected current
- Mirror design is a compromise between good optical characteristics and low electrical resistance; heterobarrier offsets in the DBR layer cause high resistance especially in the p-side
- Several modifications reducing the offsets have been introduced (for example compositional grading and doping profiling in the interfaces)

# VCSEL structure

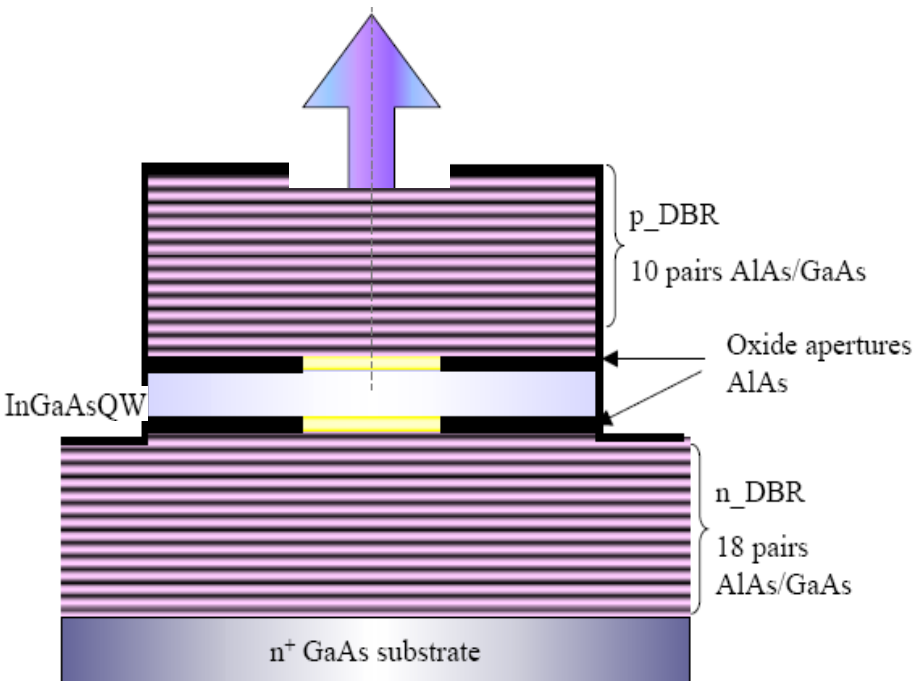
## Top emitting mesa



## Substrate emission



# VCSEL structure

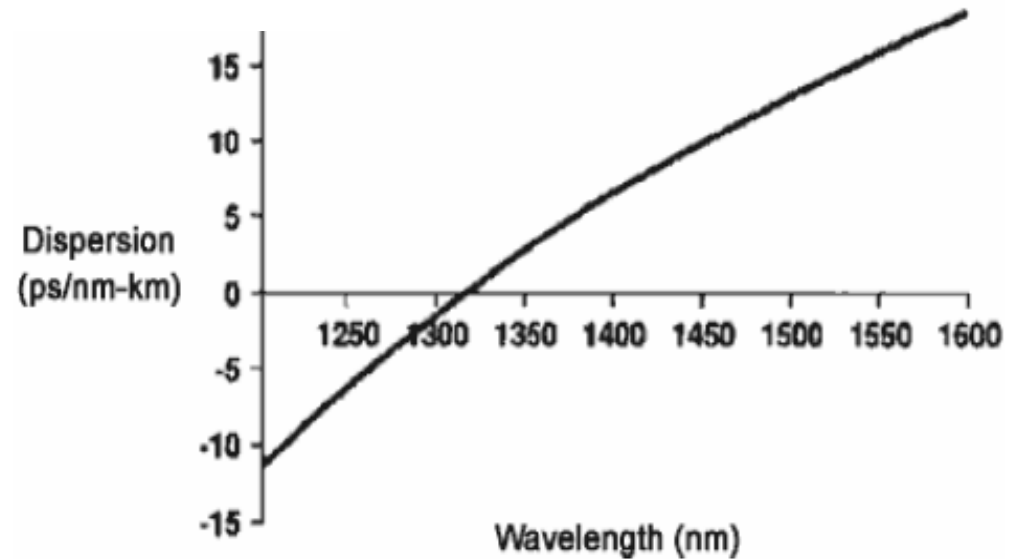
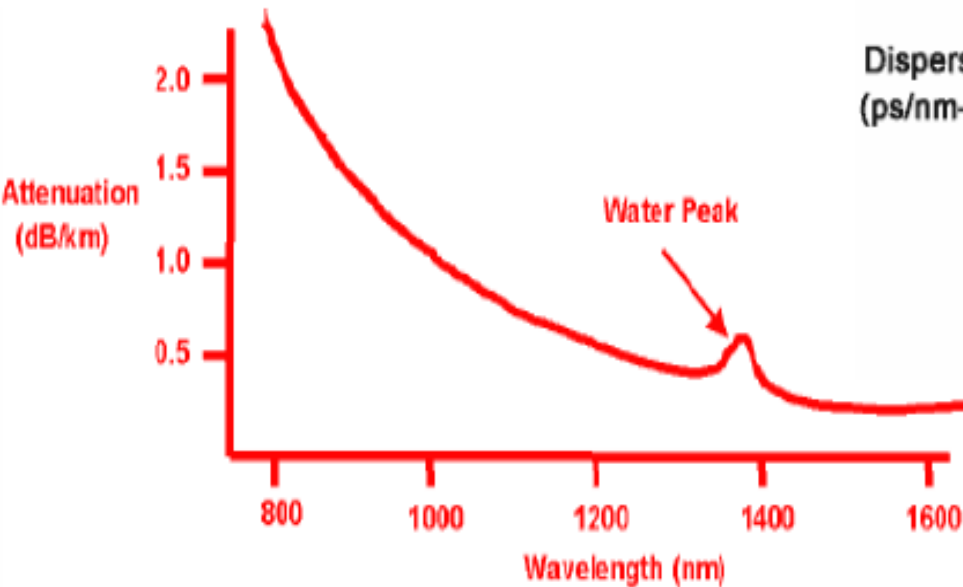


- + implant defined devices
- + intra-cavity contacted devices

- **Oxide-confined design** in an example of index-guiding
- In Al-containing alloys oxidation is highly selective: in GaAs-based structures the oxidation rate is highest for  $\text{Al}_x\text{Ga}_{1-x}\text{As}$  with  $x > 0.98$ .
- Formation of Al-oxide reduces the refractive index
- A partially oxidised AlGaAs layer forms an efficient current aperture that can be placed close to the active region to provide strong current confinement

# VCSELs for 1.3-1.55 $\mu\text{m}$

- Long wavelength VCSEL
  - 1310nm- lowest dispersion in fiber
  - 1550nm- lowest loss





# VCSELs for 1.3-1.55 $\mu\text{m}$

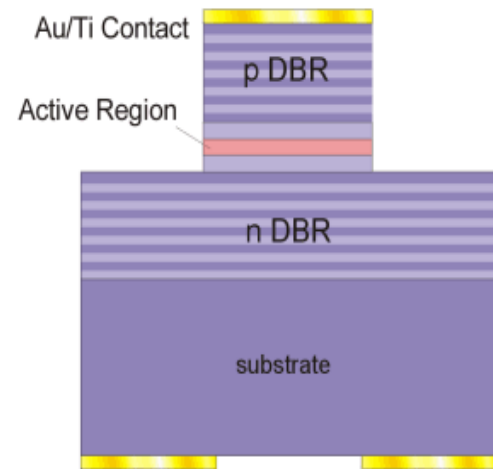
## Approaches for long wavelength VCSEL

Wavelength	Active/DBR Materials	Comment
1310 nm	GaInAsP/AlGaInAsP on InP	Monolithic DBR have low index contrast—need many periods Low modal gain from quantum well
	GaInAsP/AlGaAs (wafer bond)	Excess voltage?
	GaInAsN/AlGaAs	Material gain : As N increases, radiative efficiency decreases
	InAs quantum dots	Sufficient material gain?
1550nm	GaInAsP/AlGaInAsP on InP	Monolithic DBR have low index contrast—need many periods Low modal gain from quantum well
	GaInAsP/AlGaAsSb on InP	Extremely reactive Sb-containing DBRs.
	InGaAsN/AlGaAs	Sufficient gain at long wavelength?
	InAs quantum dots	Sufficient gain at long wavelength?

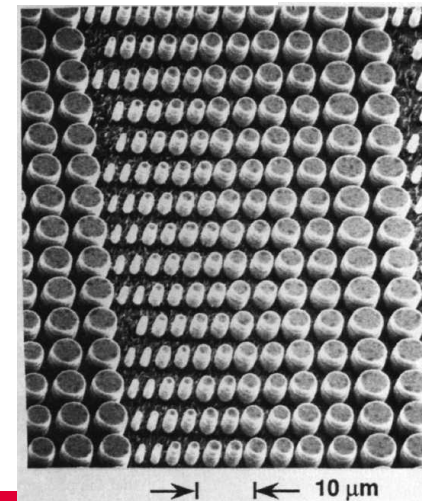
# VCSEL advantages

## Advantages of VCSELs

- **Monomode operation** due to the short cavity
- Low threshold currents
- Low beam divergence
- On-wafer testing possible (reduces costs)
- 2D VCSEL arrays possible
- Can be easily coupled (circular beam), surface-normal emission
- Low drive current needed (thin active region)
- High transmission speed with low power consumption

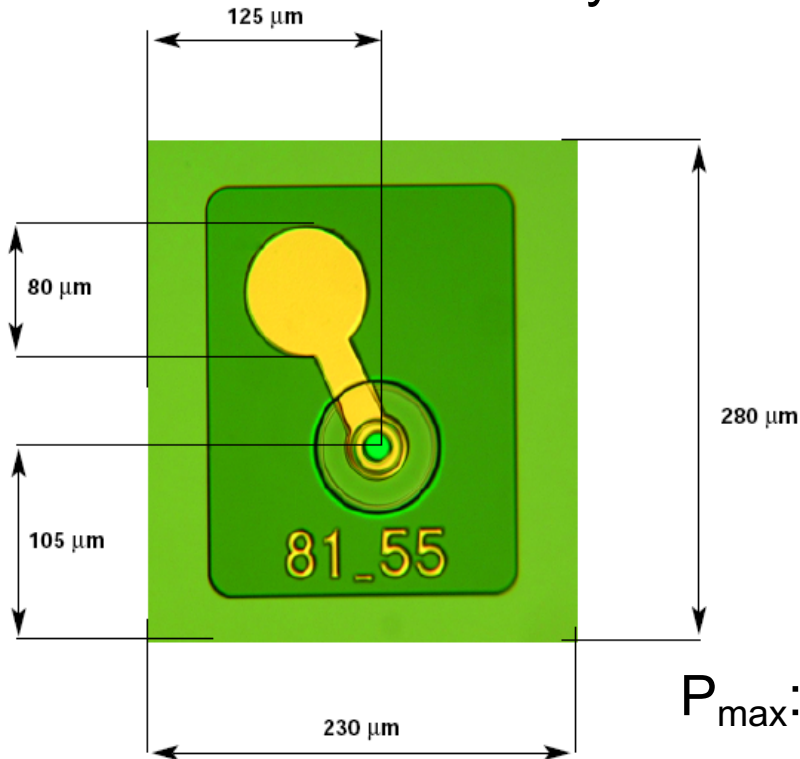


Light Out



# VCSEL applications

## Commercial VCSEL by Avalon Photonics



AVAP-850SM

Standard 850 nm  
singlemode VCSEL chip

$P_{\max}$ : 3 mW

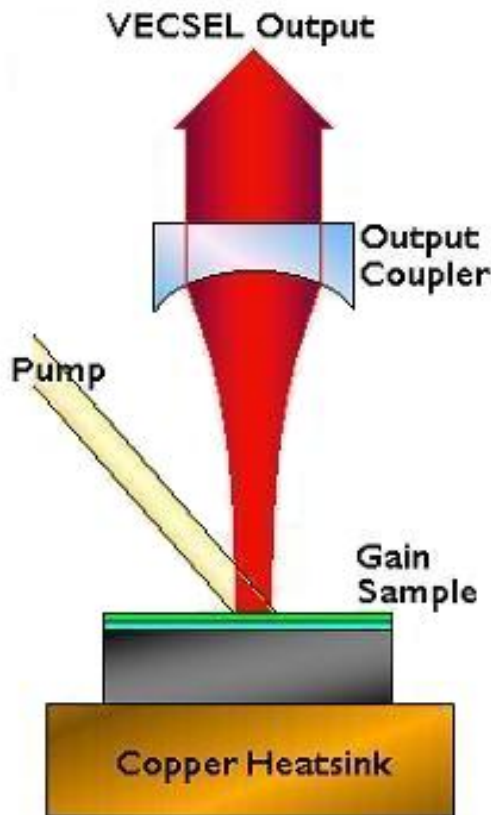
$I_{\text{th}}$ : 1-4 mA

$T_{\text{op}}$ : 0 - 70°C

## Applications

- Replacing edge-emitting lasers such as Fabry-Perot and DFB
- 1x12 arrays, 2D arrays, 3D arrays of a variety of VCSELs all coupled together driving a big set of parallel fibers
- Long haul, Metropolitan, LAN, Storage area Network
- Fiber-to-the home and two dimensional arrays for MEMS

# VECSEL



- The **external cavity** enforces a low-divergence, circular, near-diffraction-limited, high quality output beam.
- In the gain sample, a Bragg reflector is grown behind the active region.
- **Optical pumping** of the gain sample allows high power operation avoiding the problems of carrier filamentation and post-growth processing associated with electrical pumping.
- Access to external cavity allows manipulation of the laser output. Frequency doubling, mode-locking and spectroscopy are amongst these manipulative applications.

# Outline

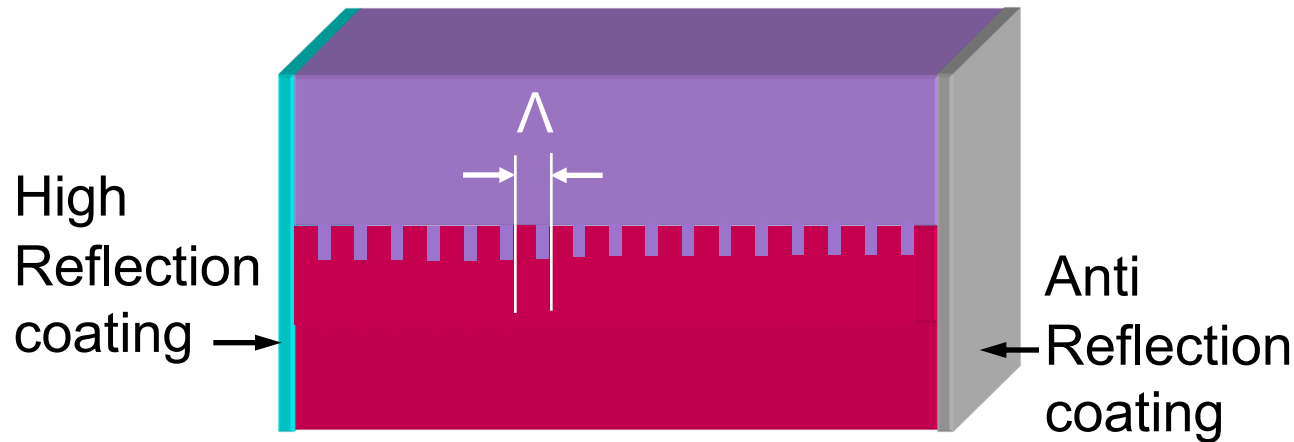
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- 1 Lateral confinement: index and gain guiding
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- 4 Quantum well lasers
- 5 Mode locking

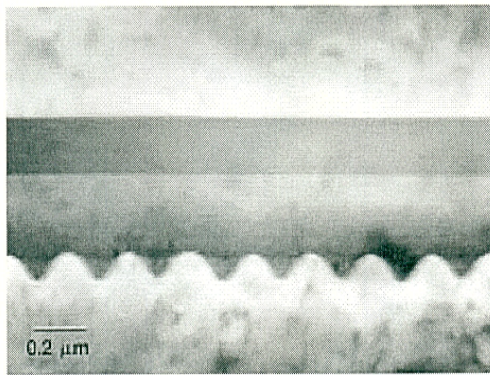
*P. Bhattacharya: chapters 6&7*

*J. Singh: chapter 10&11*

# Distributed FeedBack (DFB) Laser



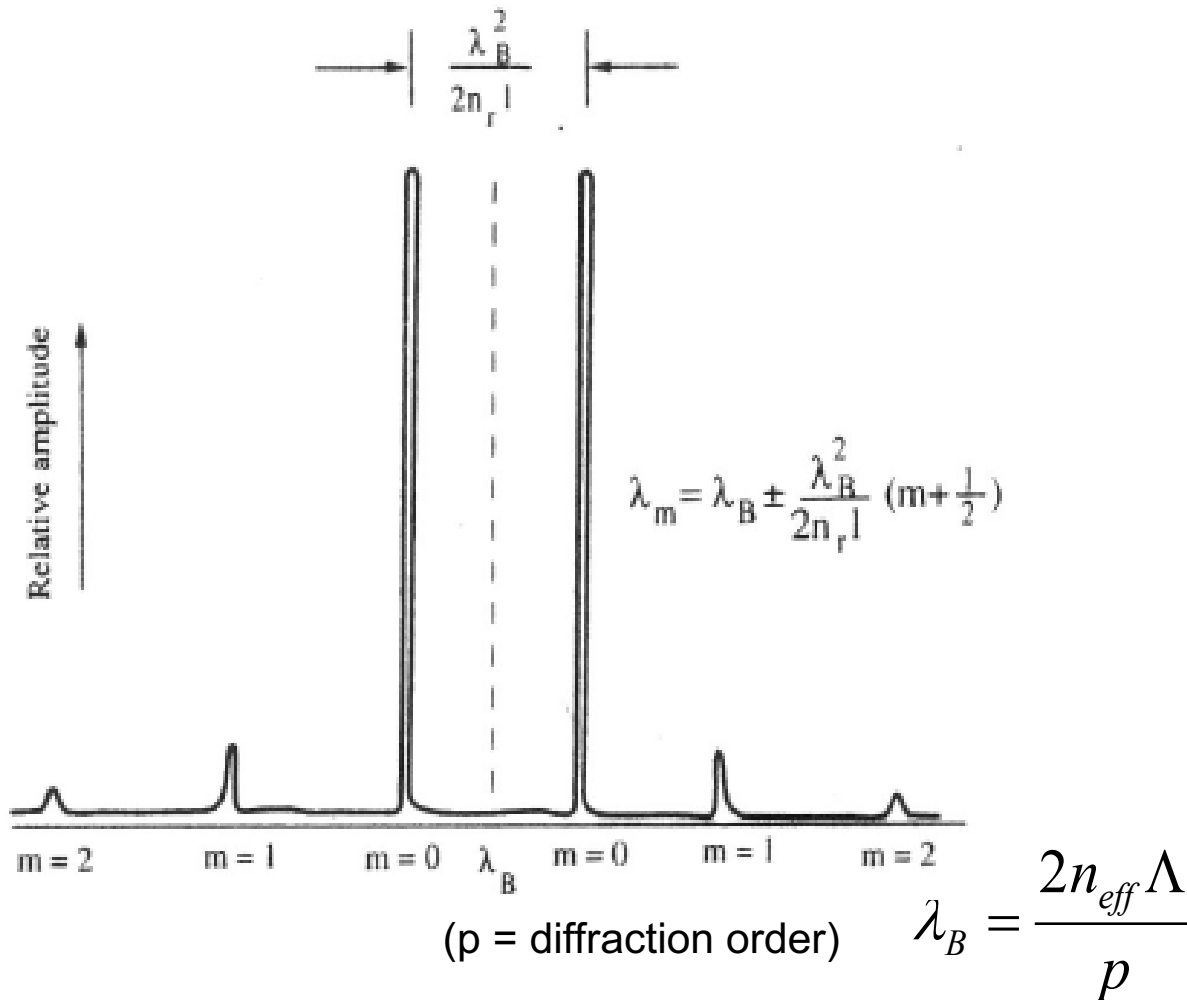
Periodic variation of refractive index along the propagation direction



*Feedback occurs due to the energy of the wave propagating in the forward direction being continuously fed back in the opposite direction by Bragg diffraction at the corrugation, or grating.*

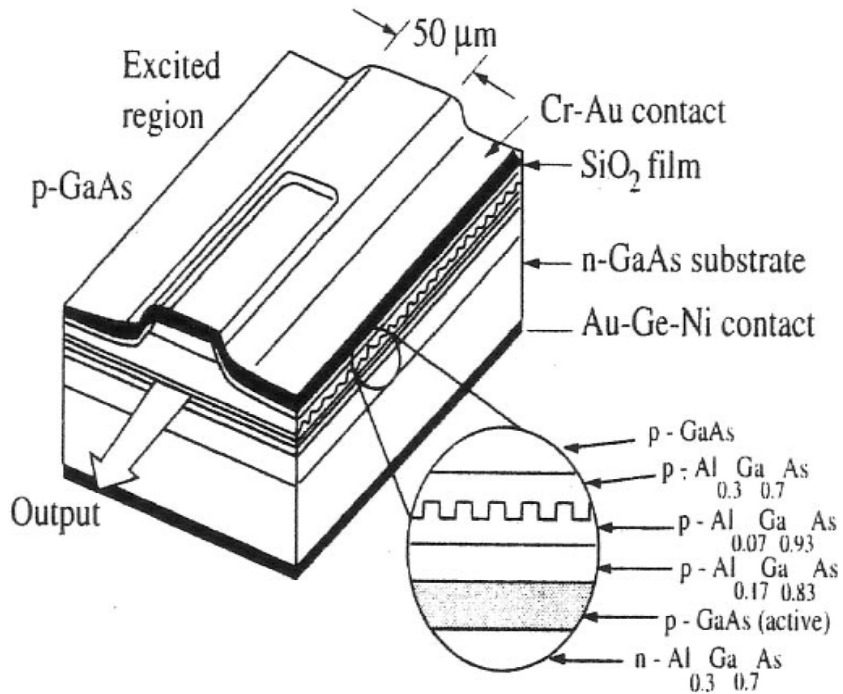
# Distributed FeedBack (DFB) Laser

The longitudinal modes of an idealized DFB laser



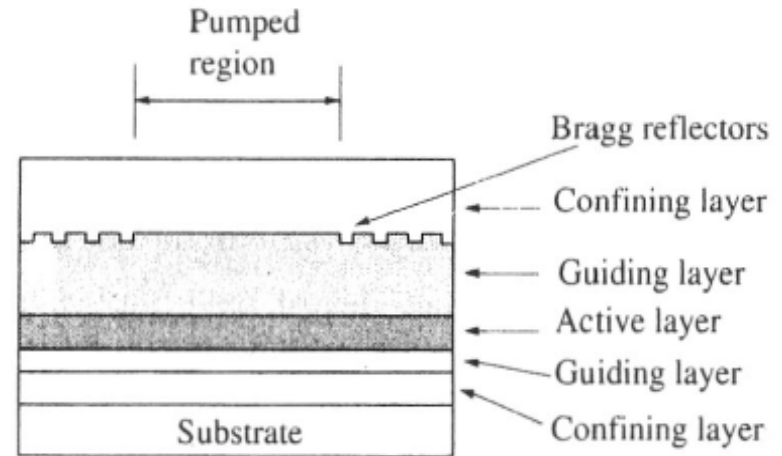
- **feedback is f-dependent:** cavity loss is different for different longitudinal modes!
- two modes on either side of Bragg resonance are the strongest
- emission is stabilized at one of these modes when the gain curve overlaps them

# DFB and DBR laser



## DFB laser

- The reflectors are within the active laser cavity



## Distributed Bragg Reflector (DBR) laser

- The reflectors are outside the active cavity region = the end mirrors are replaced by gratings



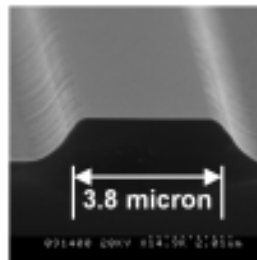
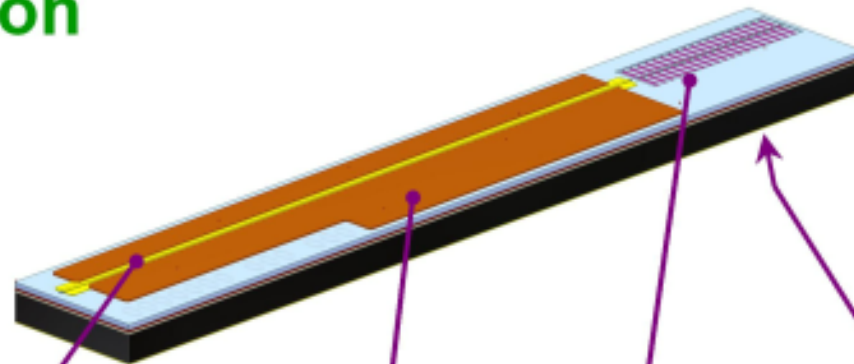
# DFB and DBR laser

## DBR Laser Fabrication

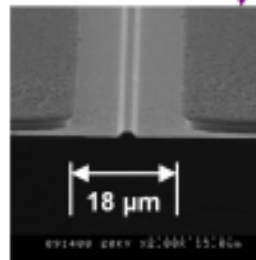
*Photodigm* 

Process Starts With:

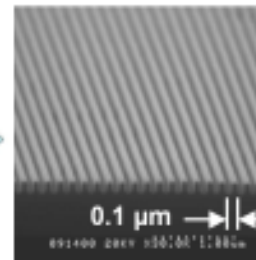
- InP based EPI, or
- AlGaAs EPI Wafers



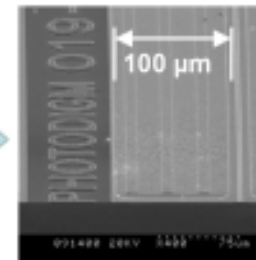
- Fabricate the Ridge



- Deposit Dielectric
- Open the Contact
- Pattern the Metal



- Fabricate the DBR Gratings



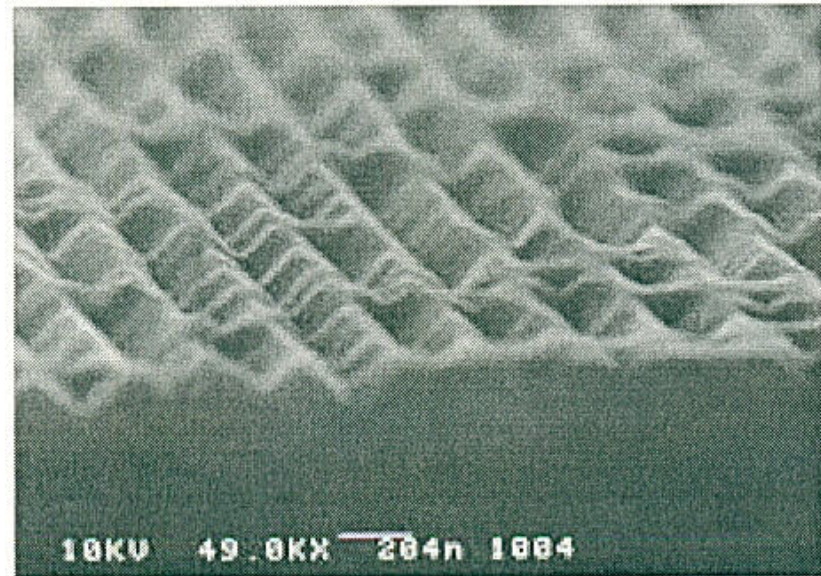
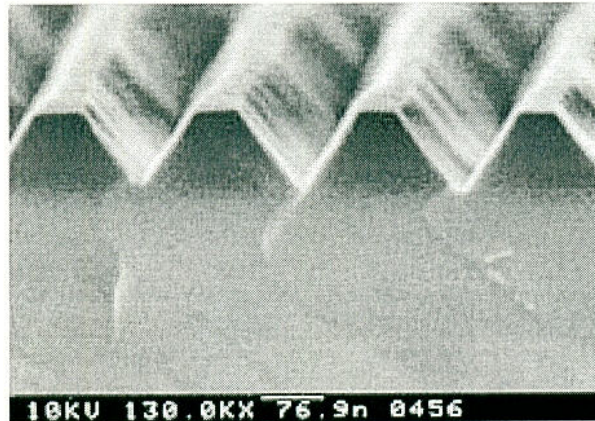
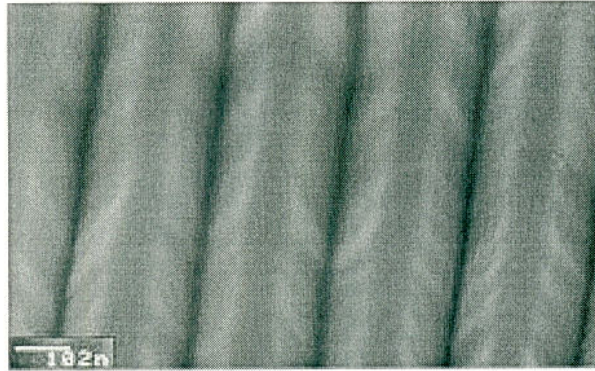
- Polish Wafer
- Add Backside Metal
- Ready for Cleaving

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# DFB grating: fabrication

---

DFB gratings are usually wet-etched. Epitaxial regrowth is then necessary to cover the grating.



# Commercial DFB laser



## Includes

- DFB diode
- Thermoelectric cooler
- Thermistor
- Photodiode
- Optical isolator
- Fiber-coupled lens

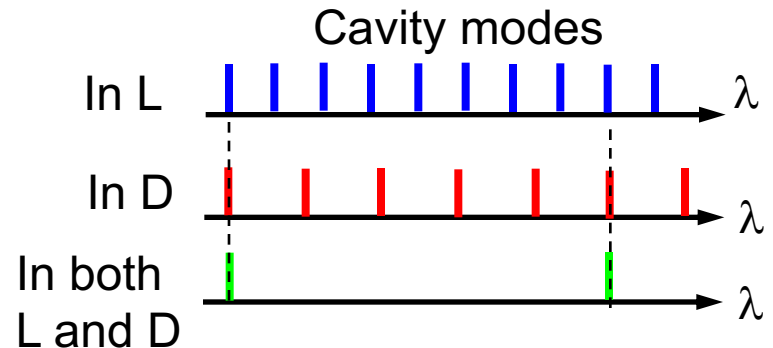
Parameters	Symbol	Min	Typ	Max	Unit
CW Output power (25C)	$P_{out}$	10	---	30	mW
Threshold current	$I_{th}$	--	25	60	mA
Operating current	$I_b$	--	300	--	mA
Forward voltage	$V_f$	--	2.0	3.0	V
Center Wavelength	$\lambda$	1540	1550	1570	nm
Linewidth	$\Delta \lambda$	--	2	--	MHz
Operating Temperature	$T_o$	-20	--	65	C
Storage temperature	$T_{stg}$	-40	--	85	C

# Cleaved Coupled Cavity (C<sup>3</sup>) Laser

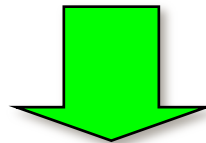
Cleaving → two shorter laser diodes with aligned cavities



$$\lambda = \frac{2Ln}{m_1} = \frac{2Dn}{m_2}$$



Longitudinal modes are required to satisfy the phase condition for both cavities

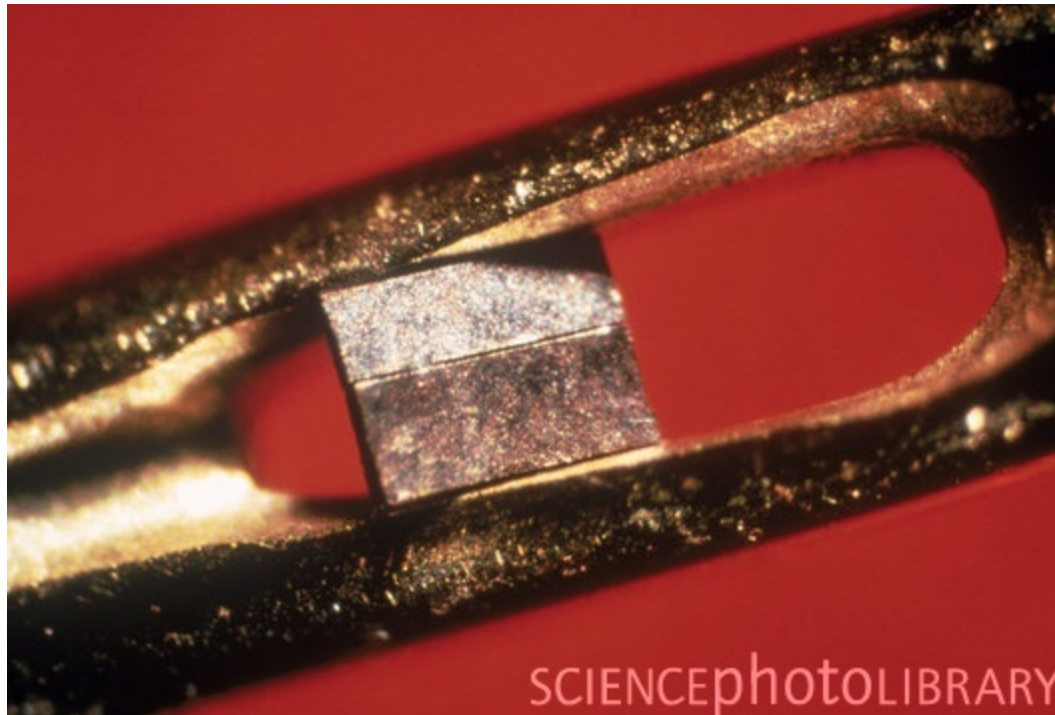


**Monomode** operation is possible since there are less modes compared to the simple Fabry-Pérot structure

Narrow spectral linewidth

# Cleaved Coupled Cavity (C<sup>3</sup>) Laser

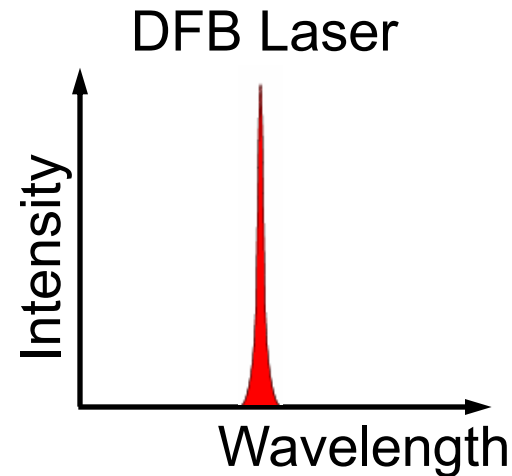
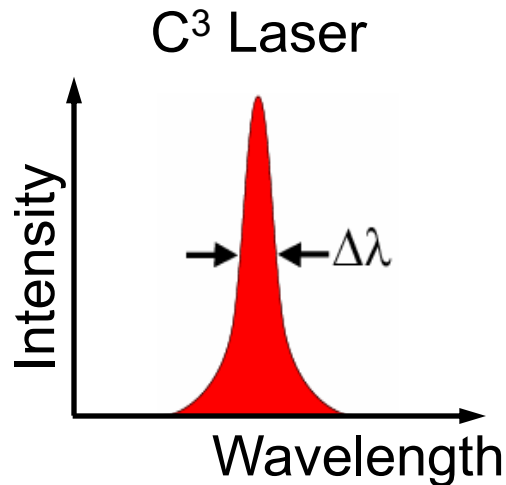
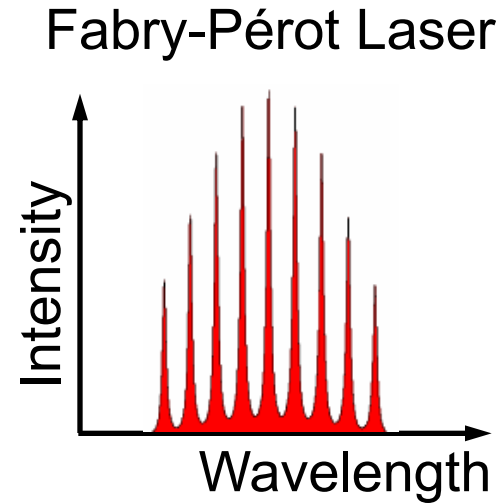
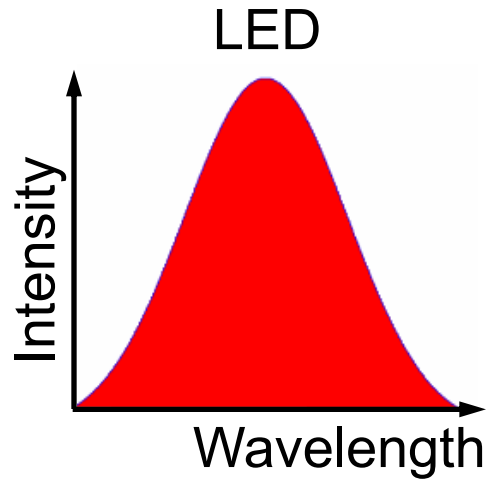
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“The cleaved-coupled-cavity (C3) laser shown in eye of a needle. A semi-conductor device can be tuned to emit a range of ultrapure frequencies, having important implications for lightwave communications systems”

# Spectrum comparison

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# Outline

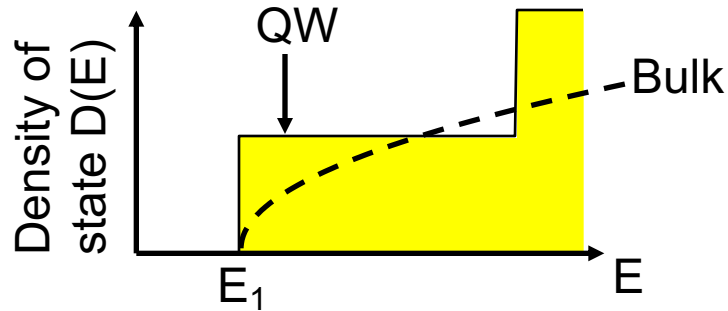
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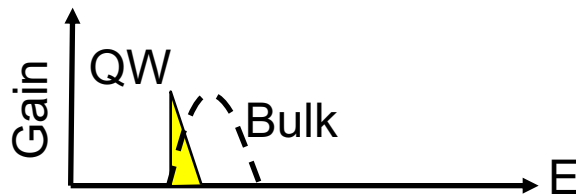
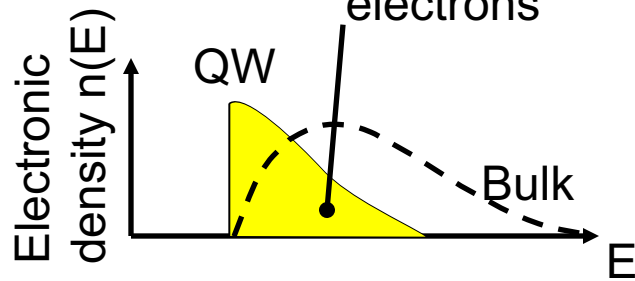
*P. Bhattacharya: chapters 6&7*

*J. Singh: chapter 10&11*

# Quantum well lasers



Area = total density of electrons



In bulk 3D case the electrons are spread over a wide energy range with a small density at the bandedges.

For QW lasers, the density of states is large at the edge of the conduction band, the electrons are spread over a smaller energy range with a high density at the subband edge.

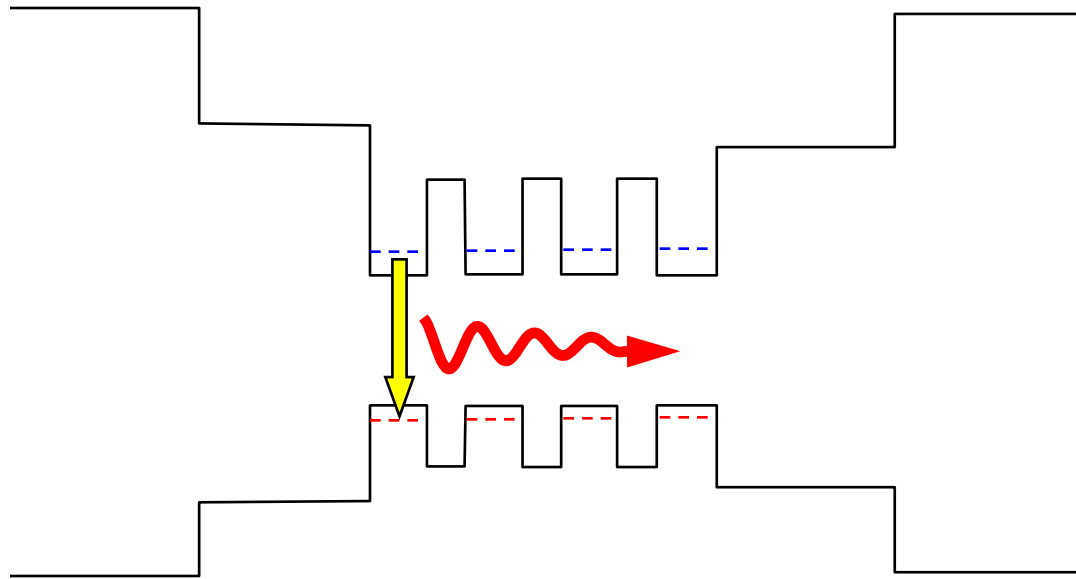
→ population inversion is achieved with a lower carrier density

→ the modal gain curve is more peaked



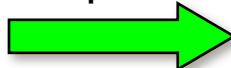
→ the threshold current is expected to be low in QW lasers



# Quantum well lasers

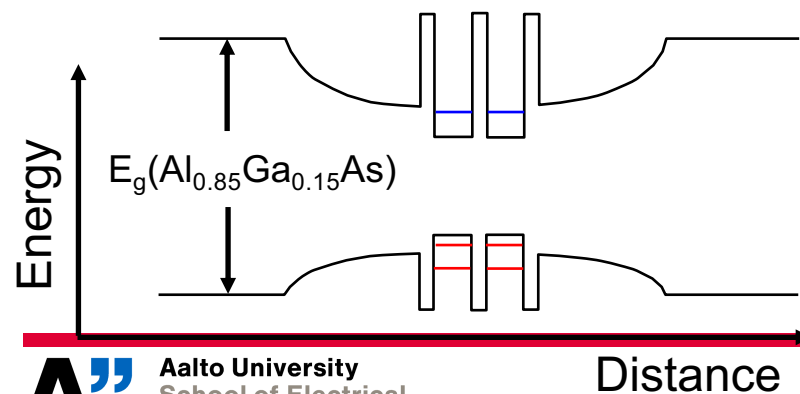
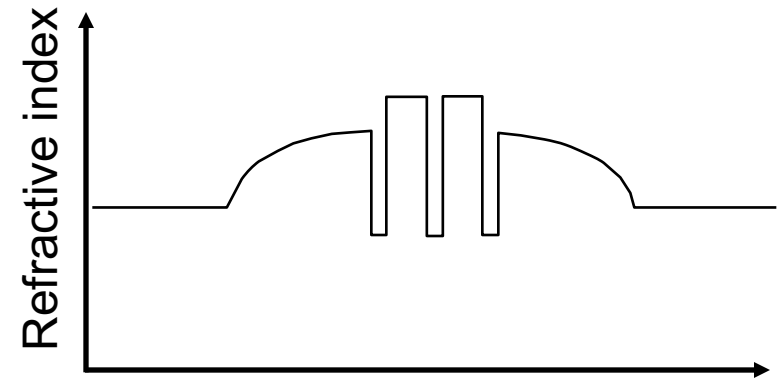
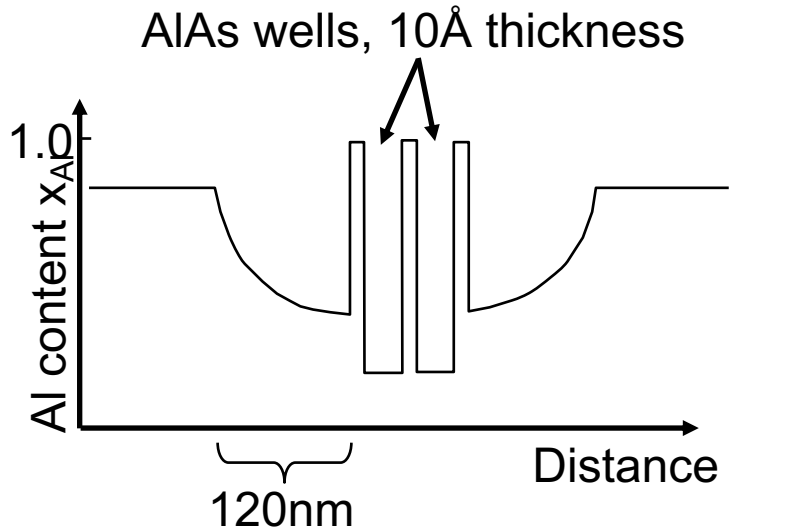


## Advantages of **quantum well lasers** (QW laser)

- Higher differential gain  Smaller  $J_{th}$
- Population inversion obtained more easily  Smaller  $J_{trans}$
- Lower temperature sensitivity
- Multiple quantum wells (MQW) coupled together increase the total thickness of active layer  higher output power

# QW lasers: Graded Index Separate Confinement heterostructure (GRIN-SCH)

Single-QW lasers suffer from poor optical confinement due to small width of the gain region.



**The graded index structure allows improving the optical confinement!**

Example:  $\text{Al}_x\text{Ga}_{1-x}\text{As}$  laser

# QW lasers: How many wells?

---

A number of QWs in the active region results in higher gain compared to a single QW laser. However, too many wells will give problems related to non-uniform injection and in strained laser structures generation of dislocations.

If the number of wells goes from 1 to  $m$ , the amount of gain required from each well decreases by a factor of  $m$ . Since  $J \sim mn^2$ , in order to benefit by using  $m$  wells, the threshold carrier density  $n$  in a well must decrease by a factor of  $m^{1/2}$  as the required gain per well drops.

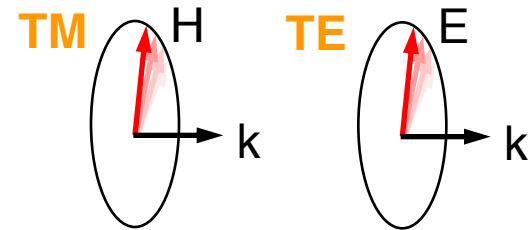
Very low threshold gain  $\rightarrow$  relatively high differential gain  $\rightarrow$  large reduction in gain means only a small reduction in carrier density and very small reduction in threshold current density

**$\rightarrow$ MQW lasers are more favored for high-current densities!**

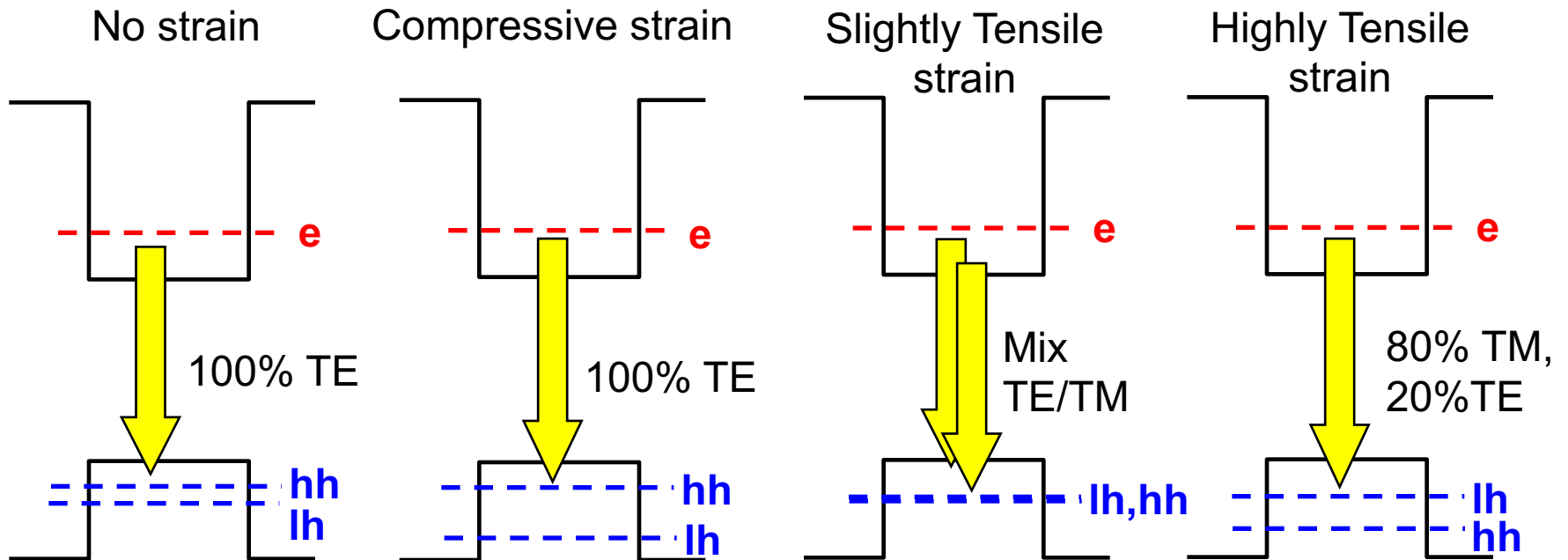
# QW lasers: polarisation

Bulk lasers (without QWs) emit a mix of TE- and TM-polarized light. The polarization of QW lasers depends on the predominant radiative recombination in the QWs:

- $hh \rightarrow e$ : 100% TE
- $lh \rightarrow e$ : 20% TE, 80% TM



The predominant recombination depends on the strain in the QWs:



# Outline

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- 1 Lateral confinement: index and gain guiding
- 2 Surface emitting lasers
- 3 DFB, DBR, and C3 lasers
- 4 Quantum well lasers
- 5 Mode locking

*P. Bhattacharya: chapters 6&7*

*J. Singh: chapter 10&11*

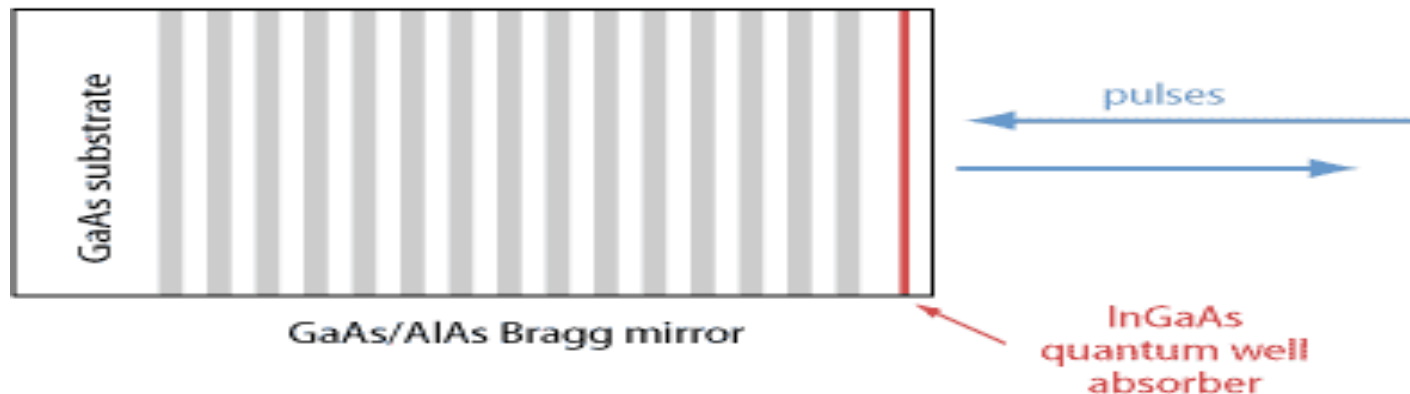
# Mode locking

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- A technique of obtaining intense narrow pulses
- The phases of mode components are locked together by external means → a periodic pulse train is formed
- Active mode-locking: a device (modulator) is inserted into the laser resonator
- Passive mode-locking: a saturable absorber is used in the laser cavity to initiate short pulse generation
- A saturable absorber is a material that has non-linearly decreasing light absorption with increasing light intensity.
- The key parameters for a saturable absorber are its wavelength range (where it absorbs), its dynamic response (how fast it recovers), and its saturation intensity and fluence (at what intensity or pulse energy density it saturates).

# Semiconductor saturable absorber mirror (SESAM)

- The SESAM is a saturable absorber that operates in reflection, thus the reflectivity increases with higher incoming pulse intensity.
- The mirror in a SESAM can be either a metallic mirror or a DBR
- QWs are used as absorbers, other layers are transparent at the operation wavelength
- Recovery time should be short (photo-generated carriers should recombine before the material can absorb light again) → a certain number of crystal defects are needed in the absorber



# SESAM: non-linear reflectivity

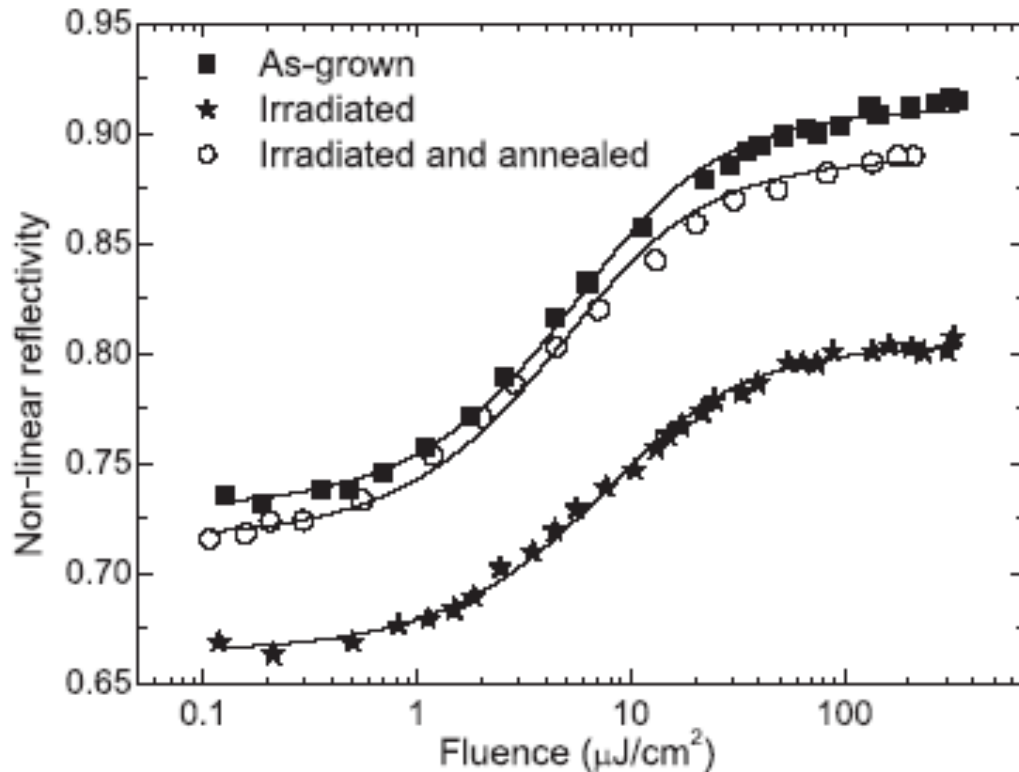


Figure 5. Non-linear reflectivity curves of as-grown, irradiated and subsequently annealed (400°C for 1 s) SESAMs. The experimental data were fitted to a theoretical model (equation (1)).

InGaAs/GaAs SESAM @ 1040 nm

Ion irradiation + subsequent annealing can be used to tune the recovery time and non-linear parameters!

Table 1. Recovery time and non-linear parameters for the as-grown SESAM and for the irradiated SESAM before and after annealing. The parameters were derived by fitting the experimental data shown in figure 5 to a theoretical model.

Sample	Non-saturable loss (%)	Modulation depth (%)	Saturation fluence ( $\mu\text{J cm}^{-2}$ )	Recovery time (ps)
As-grown	8.7	18.3	3.3	162
Irradiated	19.5	14	4.5	0.8
Irradiated, annealed	11	17.4	2.9	1.1

where  $E$  is the pulse energy fluence,  $\alpha_0$  stands for the non-saturable loss,  $\Delta R$  is the modulation depth and  $E_{\text{sat}}$  the saturation fluence.

$$R = 1 - \alpha_0 - \Delta R \frac{1 - \exp(-E/E_{\text{sat}})}{E/E_{\text{sat}}}, \quad (1)$$

T. Hakkarainen et al., J. Phys. D 38 (2005) 985-989



# Mode-locked ytterbium fiber laser tunable in the 980–1070-nm spectral range

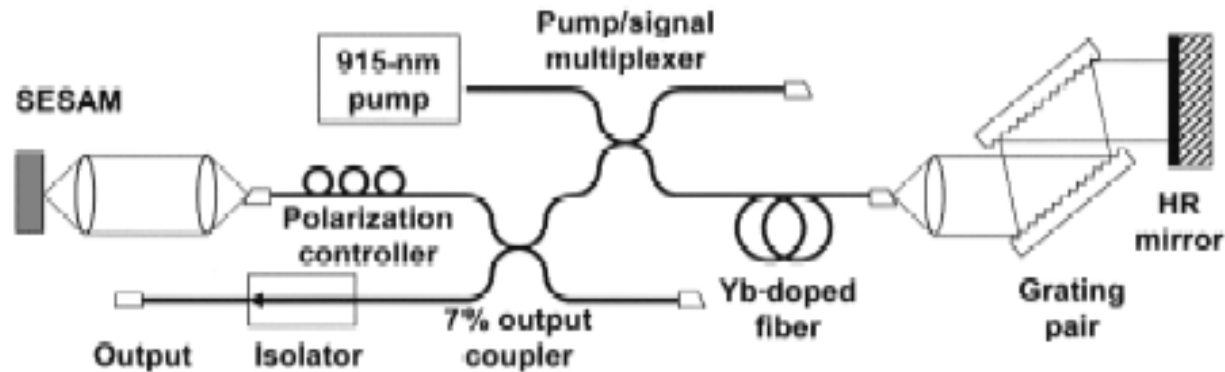


Fig. 1. Cavity configuration for a widely tunable Yb fiber laser.

Spectral tuning of a mode-locked Yb-doped fiber laser over a 90-nm range is reported. Using semiconductor saturable absorber mirrors in a fiber laser cavity incorporating a grating-pair dispersive delay line, we obtain reliable self-starting mode locking over the whole tuning range. The wide tuning range is achieved by optimization of reflection characteristics and bandgap energy of the multiple-quantum-well semiconductor saturable absorber and by proper engineering of the laser cavity. © 2003 Optical Society of America

InGaAs/GaAs SESAM  
with AlGaAs/GaAs DBRs

1.6-2 ps pulse width, 3 mW output power

O. Okhotnikov et al, 1522 OPTICS LETTERS / Vol. 28, No. 17 / September 1, 2003